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Nanoengineering: Fabrication, Properties, Optics, and Devices XIII

**Eva M. Campo
Elizabeth A. Dobisz
Louay A. Eldada**
Editors

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Contents

vii	<i>Authors</i>
ix	<i>Conference Committee</i>

SESSION 1 NANOPHOTONICS

- 9927 02 **Guided-mode resonance nanophotonics: fundamentals and applications (Invited Paper)** [9927-1]
- 9927 04 **Self-organized, effective medium black silicon antireflection structures for silicon optics in the mid-infrared** [9927-3]
- 9927 06 **Design and fabrication of titanium dioxide wire grid polarizer for the far ultraviolet spectral range** [9927-5]
- 9927 07 **Silicon nanowire photodetectors made by metal-assisted chemical etching** [9927-6]

SESSION 2 INNOVATIVE PATTERNING

- 9927 08 **Nanofabrication of low extinction coefficient and high-aspect-ratio Si structures for metaphotonic applications** [9927-8]
- 9927 09 **Dual-width plasmonic gratings with sub-10 nm gaps for biosensor applications** [9927-9]

SESSION 3 ENERGY HARVEST

- 9927 0C **Conversion of infrared light into usable energy** [9927-12]
- 9927 0E **Modified Richardson-Dushman equation and modeling thermionic emission from monolayer graphene** [9927-14]
- 9927 0F **Active control of nano dimers response using piezoelectric effect** [9927-20]

SESSION 4 METROLOGY AND PRECISION

- 9927 0G **Nanomanufacturing concerns about measurements made in the SEM Part V: dealing with noise (Invited Paper)** [9927-15]
- 9927 0I **Scanned laser inspection of SOI wafers for HVM** [9927-17]
- 9927 0K **Characterization of one-dimensional gratings fabricated by laser-focused atomic deposition** [9927-19]

9927 0M **Fabrication and characterization of one-dimensional multilayer gratings for nanoscale microscope calibration** [9927-22]

SESSION 5 NANOENGINEERED MATERIALS

9927 0R **Tapered optical fiber tip probes based on focused ion beam-milled Fabry-Perot microcavities** [9927-27]

SESSION 6 NANODEVICE ENGINEERING

9927 0V **Nanofabrication and test of novel diffractive optics for OAM-mode division multiplexing in optical fibers** [9927-31]

9927 0W **Design and fabrication of Fourier spectral filter array for multispectral imaging** [9927-32]

SESSION 7 NANO-OPTIC DEVICES

9927 0Z **Improved optical enhancement in binary plasmonic gratings with nanogap spacing** [9927-35]

9927 11 **Surface characterization of nanostructured 'black silicon' using impedance spectroscopy** [9927-37]

9927 12 **Characterization of random anti-reflecting surface structures and their polarization response at off-normal angles of incidence** [9927-38]

9927 13 **Holographic imaging with single pixel sensor** [9927-39]

SESSION 8 NANOSTRUCTURE PROPERTIES

9927 15 **Silver nanorod structures for metal enhanced fluorescence** [9927-41]

9927 16 **Modeling thermionic emission from carbon nanotubes with modified Richardson-Dushman equation** [9927-43]

POSTER SESSION

9927 1B **Photovoltaic effects as the physical basis of a new generation of microelectromechanical sensors and systems (MEMS)** [9927-48]

9927 1I **Growth technique and effect of post growth annealing on the optical properties of In(Ga)As/GaAs quantum dot heterostructures** [9927-55]

9927 1J **A detailed investigation of the impact of varying number of dot layers in strain-coupled multistacked InAs/GaAs quantum dot heterostructures** [9927-56]

- 9927 1K **High resolution measurement of water levels in optical components** [9927-57]
- 9927 1M **Cliché fabrication method using precise roll printing process with 5 um pattern width**
[9927-59]
- 9927 1N **A characterization method for the metal thin film** [9927-60]
- 9927 1Q **Ion-assisted evaporation of vanadium dioxide thin films** [9927-63]
- 9927 1R **Raman spectral analysis of high efficiency PVDF: nanocomposite films doped with MWCNT**
[9927-64]
- 9927 1S **Induced changes in refractive index, optical band gap, and absorption edge of polycarbonate-SiO₂ thin films by Vis-IR lasers** [9927-66]
- 9927 1T **Excitation of silicon microspheres resonances with femtosecond laser fabricated glass waveguides** [9927-67]

Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Adhikary, Sourav, 1I
Aggarwal, Ishwar D., 12
Ahmad, Aijaz, 1I
Akhoondi, Somaieh, 1S
Ali, Tamer A., 0F
André, Ricardo M., 0R
B. Marques, Manuel, 0R
Badawi, Ashraf H., 0F
Badshah, Mohsin Ali, 15
Baik, Chan-Wook, 08
Balgarkashi, Akshay, 1J
Bartelt, Hartmut, 0R
Bauman, Stephen J., 09, 0Z
Becker, Martin, 0R
Bharadwaj, Vibhav, 1T
Brawley, Zachary T., 0Z
Busse, Lynda E., 12
Case, Jason R., 12
Chakrabarti, Subhananda, 1I, 1J
Chang, Yushan, 0I
Chen, Jie, 0K, 0M
Cheng, Xinbin, 0K, 0M
Çirkinoğlu, Hüseyin Ozan, 1T
Darweesh, Ahmad A., 09, 0Z
De, Dilip K., 0E, 16
Dellith, Jan, 0R
Deng, Xiao, 0K
Duan, Wenqi, 1I
Eaton, Shane M., 1T
Ehsani, Hassan, 1S
Filonov, Oleg, 1B
Frantz, Jesse A., 12
Frazão, Orlando, 0R
Ghadi, Hemant, 1I, 1J
Given, Robert P., 0C
Gökay, Ulaş Sabahattin, 1T
Guggilla, Padmaja, 1R
Han, Seunghoon, 08
Hernandez-Balbuena, Daniel, 1K
Herzog, Joseph B., 09, 0Z
Hirakawa, Keigo, 0W
Hwang, Do Kyung, 13
Jeong, Heejeong, 08
Jia, Jie, 0W
Ju, Jonghyun, 15
Kaczmar, Justin M., 0C
Käsebier, Thomas, 04
Kassu, Aschalew, 1R
Kim, Inyoung, 1M
Kim, Jaekwan, 08
Kim, Seok-min, 15
Kim, Yongsung, 08
Kley, Ernst-Bernhard, 04, 06
Ko, Yeong Hwan, 02
Kroker, Stefanie, 06
Latifi, H., 0R
Lee, Chang Seung, 08
Lee, Chang-Won, 08
Lee, JeongYub, 08
Lee, Taik-Min, 1M
Lee, Young Tack, 13
Leportier, Thibault, 13
Li, Tongbao, 0K, 0M
Liu, Chao, 1N
Liu, Jie, 0K, 0M
Liu, Qinggang, 1N
Lu, Xun, 15
Ma, Yan, 0K
Magnusson, Robert, 02
Marinelli, Zachary J., 0C
Massari, M., 0V
Meeks, Steven W., 0I
Mekrawy, Ahmed A., 0F
Murrieta-Rico, Fabian N., 1K
Ni, Chuan, 07, 0W, 1Q
Oh, Dong-Ho, 1M
Olawole, Olukunle C., 0E, 16
Oskolkov, Boris, 1B
Panda, Debiprasad, 1I, 1J
Park, Min-Chul, 13
Petranovskii, Vitalii, 1K
Postek, Michael T., 0G
Poutous, Menelaos K., 12
Powell, Rachel, 1R
Prussak, Nikolay, 1B
Qin, Zirui, 1N
Ramponi, Roberta, 1T
Raymond-Herrera, Oscar, 1K
Romanato, F., 0V
Rothhardt, Manfred, 0R
Ruffato, G., 0V
Sanghera, Jasbinder S., 12
Sapkota, Gopal, 12
Sarangan, Andrew, 07, 0W, 1Q
Scarel, Giovanna, 0C
Sergiyenko, Oleg, 1K
Serpengüzel, Ali, 1T
Shaw, L. Brandon, 12

Shetty, Saikalash, 1J
Shin, Yejin, 1M
Siefke, Thomas, 06
Song, Byonggwon, 08
Sotillo, Belén, 1T
St. John, Thomas C., 0C
Steglich, Martin, 04
Toor, Fatima, 11
Tünnermann, Andreas, 04, 06
Utter, Brian C., 0C
Valley, John F., 0I
Velidandla, Vamsi, 0I
Vladár, András E., 0G
Wang, Xingrui, 0K, 0M
Warren-Smith, Stephen C., 0R
Wenger, Kyle S., 0C
Xie, Xian, 1N
Xu, Ying, 07
Zhao, Yang, 0M
Zibaii, M. I., 0R
Zou, Mengyang, 1Q

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